



Physical Interfaces & Carriers North America TC Chapter

SEMI Standards NA Spring Meetings 2026
Wednesday, May 13 | 09:00–12:00 Noon Eastern

AGENDA

	Time
1 Welcome/Call to Order	09:00
1.1 Please log in at https://web.portal.semi.org/home for voting (select “Meetings”)	
1.2 Required Elements (Membership Requirements, Antitrust and Intellectual Property Reminders, and Effective Meeting Guidelines)	
1.3 Introductions	
1.4 Agenda Review	
2 Review of Previous Meeting Minutes	09:15
3 Liaison Report (Japan)	09:20
4 Staff Report	09:25
5 Ballot Review	
None	
6 Subcommittee & Task Force Reports	09:35
6.1 “6x12” Reticle Carrier & Load Port Task Force	
6.2 Electron Microscopy Workflow Task Force	Break?
6.3 SEMI E72 Revision Task Force	10:30-10:40
6.4 Film Frame FOUP (FFF) Task Force	
6.5 Next Gen Assembly/Test Material Handling Japan Task Force	
6.6 Integrated Workflows in Failure Analysis Task Force	
6.7 Global PIC Maintenance Task Force	
7 Old Business	11:00
7.1 Five-Year Review (<i>None</i>)	



	Time
8 New Business	11:15
9 Action Item Review	11:30
10 Next Meeting and Adjournment	11:40

10.1 The next SEMI Standards NA Meetings are scheduled for the week of October 12-15, 2026, in conjunction with SEMICON West in San Francisco, CA. Schedule details TBD.
<https://www.semiconwest.org/>.

Tentative Schedule (Pacific):

- TBD, Next Gen Assembly / Test Material Handling (NGAT) Japan TF
- TBD, Integrated Workflows in Failure Analysis TF
- TBD, “6 x12 inch” Reticle Carrier and Load Port TF (*virtually*)
- 16:00-17:00 Pacific; E72 Revision Task Force (*virtually*)

Monday, October 12

- Open

Tuesday, October 13

- 15:00-16:00, Electron Microscopy Workflow TF

Wednesday, October 14

- 08:30-09:00 / 09:00-09:30, Global PIC Maintenance TF
- 09:00 / 09:30-12:00 Noon, PIC NA TC Chapter Meeting

20260413
LNN
v1